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Sheet	1	of	2	Application Number	4 10/826,018
				Filing Date	
				First Named Inventor	Chiwoe Wayne Lo
				Art Unit	2861 2881
				Examiner Name	Judy Nguyen Jack Bernagh
				Attorney Docket Number	6317P090D2

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Signature	Jack Berman	Date Considered	9/28/2005
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Sheet

2

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
JB		T.R. GROVES, et al., "Distributed, multiple variable shaped electron beam column for high throughput maskless lithography", J. Vac. Sci. Technol., B 16(6), Nov/Dec 2000, pp. 3168-3173	
JB		E. YIN, et al., "Electron optical column for a multicolumn, multibeam direct-write electron beam lithography system", J. Vac. Sci. Technol., B 18(6), Nov/Dec 2000, pp. 3126-3131	
JB		A. KHURSHEE, "Permanent magnet objective lenses for multicolumn electron-beam systems", Review of Scientific Instruments, Vol. 72, Number 4, April 2001, pp. 2106-2109	
JB		EIICHI GOTO et al., "MOL (moving objective lens) Formulation of deflective aberration free system", Optik, 48 (1977), No. 3, pp. 255-270	

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